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02/21/02

PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10080319	02/21/2002	430		1753	THURNTON

**APPLICANTS: Lee Geun; Jung Jae; Shin Ki;

yes

**CONTINUING DATA VERIFIED:

None yet

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** FOREIGN APPLICATIONS VERIFIED:

REPUBLIC OF KOREA 2001-38026 06/29/2001

PG-PUB DO NOT PUBLISH ☐

RESCIND ☐

Foreign priority claimed ☒ yes ☐ no

35 USC 119 conditions met ☒ yes ☐ no

Verified and Acknowledged Examiners's initials


yes

ATTORNEY DOCKET NO

30205/38088

TITLE : Photoresist monomers, polymers thereof and photoresist compositions containing the same

U.S. DEPT. OF COMM./PAT. & TM.-PTO-436L (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED		
			Total Claims	Print Claim for O.G.	
ISSUE FEE		Primary Examiner	DRAWING		
Amount Due	Date Paid		Sheets Drawn	Figs. Drawn	Print Fig.
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE	Application Examiner		
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